

APPLICATION DATA SHEET

Application Information

Application number::
Filing Date::
Application type:: Regular
Subject Matter:: Utility
Title line one:: LSI INSPECTION METHOD AND
Title line two:: DEFECT INSPECTION DATA
Title line three:: ANALYSIS APPARATUS
Attorney Docket Number:: 037133.53131US
Request for Early Publication?:: No
Request for Non-Publication?:: No
Suggested Drawing Figure:: 1
Total Drawing Sheets:: 4
Small Entity?:: No
Petition included?:: No
Petition Type::

Applicant Information

Applicant Authority Type:: Inventor
Primary Citizenship:: Japanese
Country:: Japan
Status:: Full Capacity
Given Name:: Yoji
Family Name:: Hata
Country of Residence:: Japan
Street of mailing address:: c/o UMC Japan
1580 Yamamoto
Tateyama City
City of mailing address::
State or Province of
Mailing address:: Chiba
Country of mailing
address:: Japan
Postal or Zip Code
of mailing address:: 294-8502

Correspondence Information

Correspondence Customer
Number::



23911

PATENT TRADEMARK OFFICE

Representative Information

Representative customer number::



23911

PATENT TRADEMARK OFFICE

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
JP	106271/2003	April 10, 2003	Yes

Assignee Information

Assignee Name:: UMC Japan
Street of mailing address:: 1580 Yamamoto
City of mailing address:: Tateyama City
State or Province of
Mailing address:: Chiba
Country of mailing
address:: Japan
Postal or Zip Code
of mailing address:: 294-8502